



# Low energy electron modelling in PyECLOUD

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**Acknowledgements:** Thanks to Giovanni Iadarola for helpful discussions and input.

# Outline

Introduction

Theory of secondary electron emission

The macroparticle approach

Comparison of models and implementation

Comparison of simulation output

Summary

# Introduction

In this presentation we will study two of the available secondary emission modules in PyECLoud [1]. Specifically we will study and compare the standard secondary emission module,

- `sec_emission_model_ECLOUD.py`

with the secondary emission module for more accurate treatment of low energy electrons,

- `sec_emission_model_accurate_low_ene.py`.

# Theory of secondary electron emission

# Secondary electron emission

- Is described by  $\delta$ , the secondary electron yield (SEY)

$$\delta = \frac{I_{emit}}{I_{imp}}$$

- $\delta$  depends on the energy of the impacting electrons as well as the angle of incidence
- $\delta$  can be divided into components,

$$\delta = \delta_{elas} + \delta_{true} (+\delta_{rediff})^1$$

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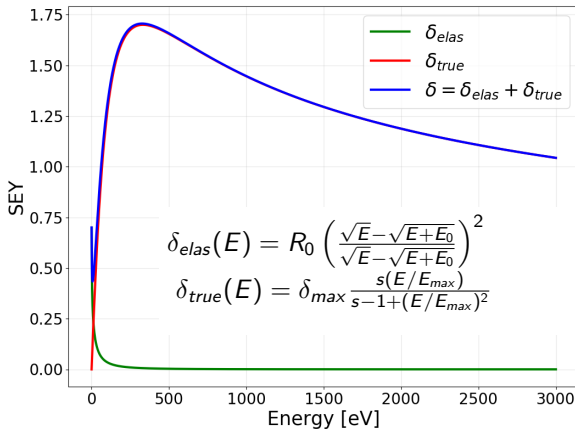
<sup>1</sup>Not used in PyECLoud but sometimes by others, e.g. Furman and Pivi [2]

# The SEY Curve

Let's have a closer look at the SEY components of PyECLOUD.

# The SEY Curve

For high electron energies  $\delta_{true}$  makes up most of  $\delta$  and the contribution from  $\delta_{elas}$  is negligible.

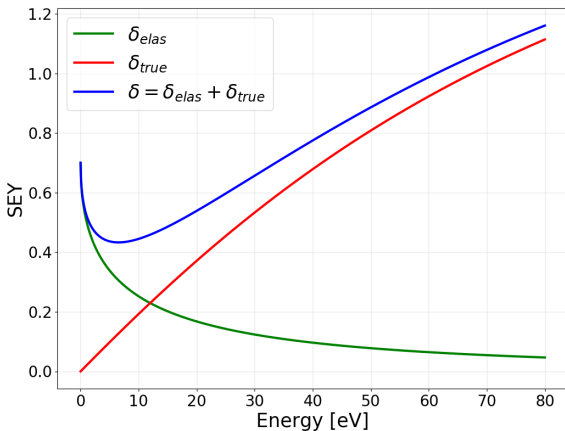




# The SEY Curve

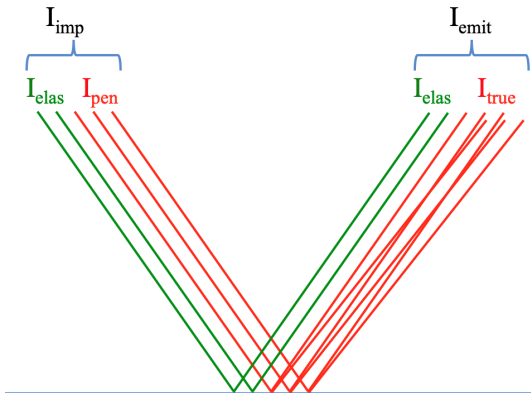
For low electron energies  $\delta_{elas}$  plays an important role.

Consequently, a difference in treatment of the elastic SEY component mainly affects low energy electrons.



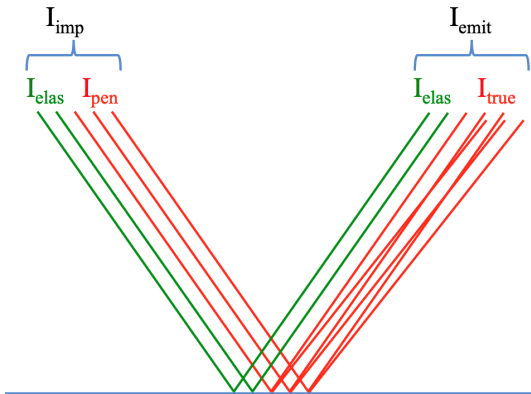
# The SEY components

- $\delta = \frac{I_{emit}}{I_{imp}}$
- $\delta_{elas} = \frac{I_{elas}}{I_{imp}}$
- $\delta_{true} = \frac{I_{true}}{I_{imp}}$



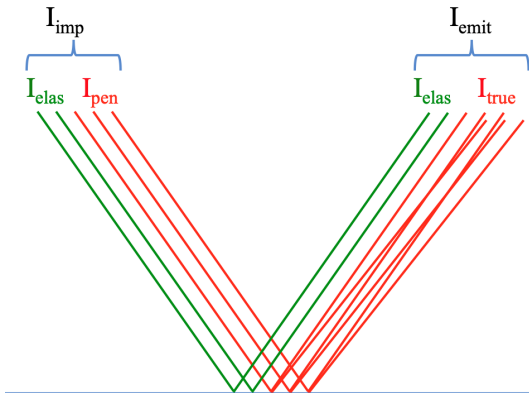
# The SEY components

- $\delta = \frac{I_{emit}}{I_{imp}} = \delta_{elas} + \delta_{true}$
- $\delta_{elas} = \frac{I_{elas}}{I_{imp}}$
- $\delta_{true} = \frac{I_{true}}{I_{imp}}$



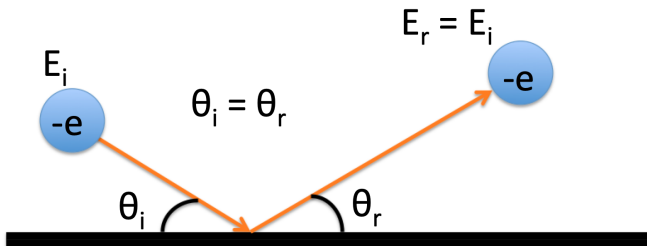
# The SEY components

- $\delta = \frac{I_{emit}}{I_{imp}} = \delta_{elas} + \delta_{true}$
- $\delta_{elas} = \frac{I_{elas}}{I_{imp}}$
- $\delta_{true} = \frac{I_{true}}{I_{imp}}$
- $\hat{\delta}_{true} = \frac{I_{true}}{I_{pen}}$   
“number of emitted electrons per non-elastic event”



# Elastic collision events

- Energy does not change
- Angle of incidence equals angle of reflection



# True secondary collision events

- True secondary electrons are generated at various angles and various energies

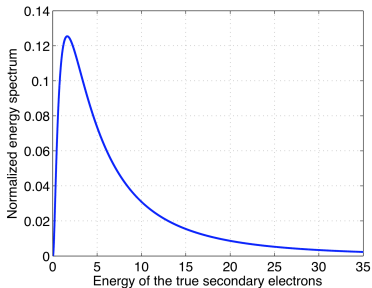
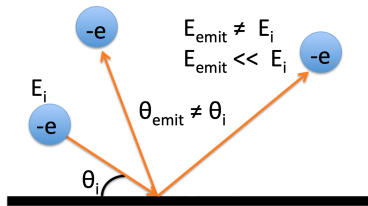
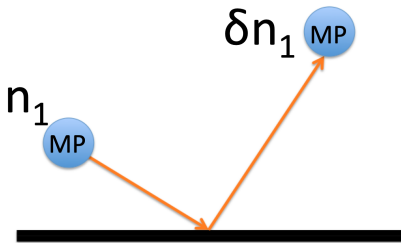


Figure: G. Iadarola [3]

# The macroparticle approach

# The macroparticle approach

- Due to computational limitations we cannot track individual electrons
- Instead we use macroparticles (MPs), each representing many electrons
- We rescale the MP size instead of adding or removing electrons





# Comparison of models and implementation

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From here on we will refer to the standard module as ECLLOUD and the module for more accurate low energy electron modelling as ACC\_LOW.

# Comparison of models and implementation

The two modules differ in terms of

- Deciding event type of each collision event (elastic or true secondary)
- Rescaling the MPs

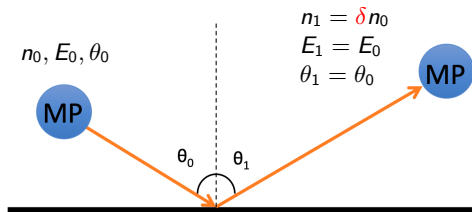
# The ECLLOUD module

# The ECLoud module

## Elastic

$$P(\text{elas}) = \frac{I_{\text{elas}}}{I_{\text{emit}}} = \frac{\delta_{\text{elas}}}{\delta}$$

*probability that an emitted electron comes from an elastic event*

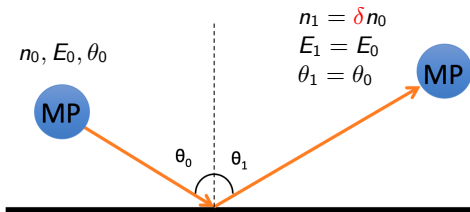


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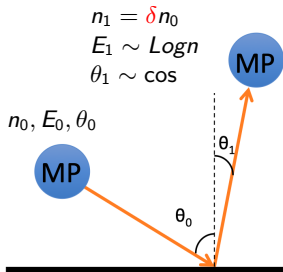
probability that an emitted electron comes from an elastic event



## True secondary

$$P(\text{true}) = \frac{I_{\text{true}}}{I_{\text{emit}}} = \frac{\delta_{\text{true}}}{\delta}$$

probability that an emitted electron comes from a true secondary event



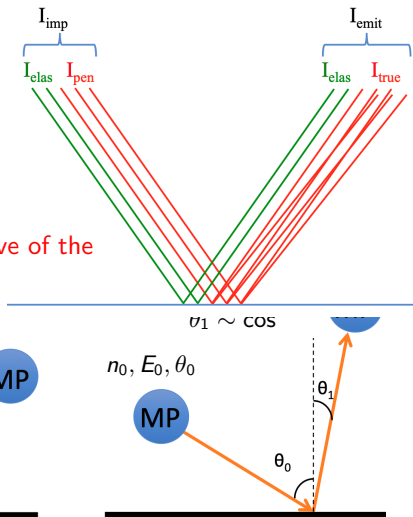
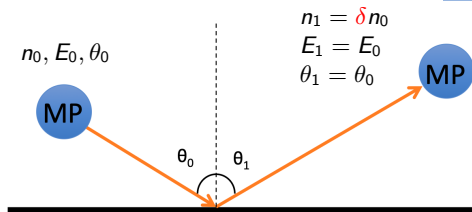
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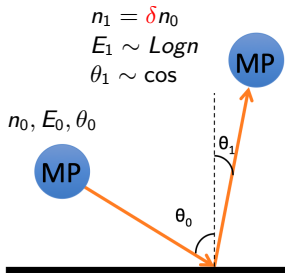
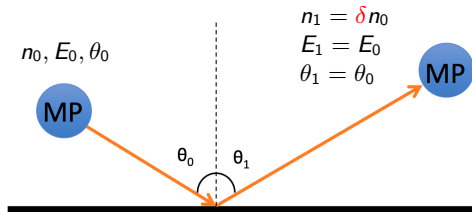
Probabilities are defined from a perspective of the emitted electrons



# The ECLoud module

**Note:** Since we rescale elastically scattered MPs, energy conservation is not respected on single events if  $\delta > 1$ .

(Averaged over all events, energy conservation is respected)





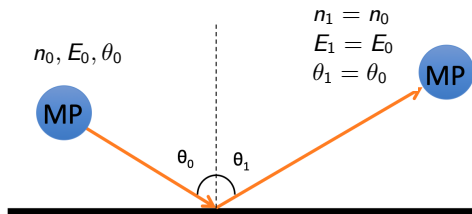
# The ACC\_LOW module

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## Elastic

$$P(\text{elas}) = \frac{I_{\text{elas}}}{I_{\text{imp}}} = \delta_{\text{elas}}$$

*probability that an impacting electron will become elastically scattered*



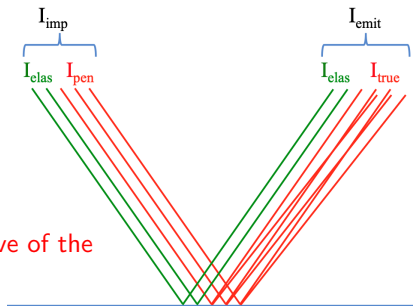
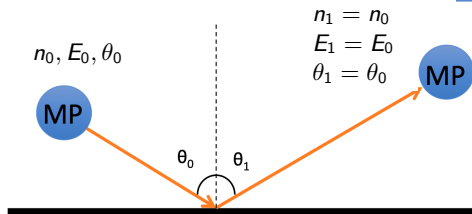
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Probabilities are defined from a perspective of the impacting electrons



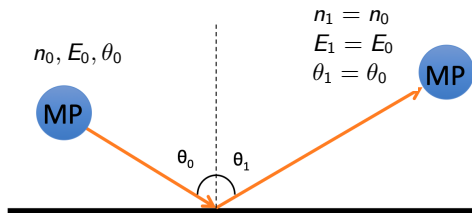
# The ACC\_LOW module

## Elastic

$$P(elas) = \frac{I_{elas}}{I_{imp}} = \delta_{elas}$$

probability that an impacting electron will become elastically scattered

Probabilities are defined from a perspective of the impacting electrons



## True secondary

$$P(true) = 1 - P(elas) = 1 - \delta_{elas}$$

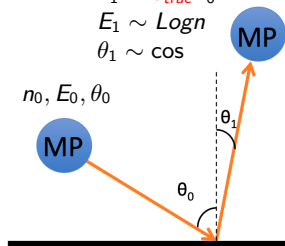
probability that an impacting electron will be in a true secondary event

Note:  $\hat{\delta}_{true} \neq \delta$

$$n_1 = \hat{\delta}_{true} n_0$$

$$E_1 \sim \text{Log}n$$

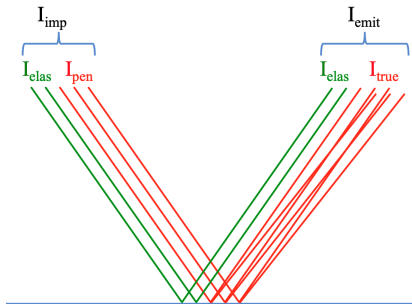
$$\theta_1 \sim \cos$$



What is  $\hat{\delta}_{true}$ ?

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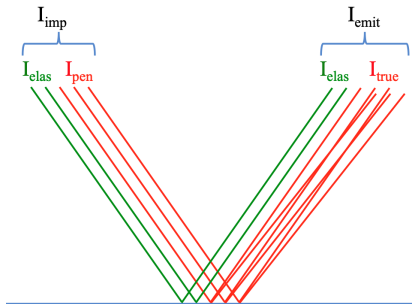
- $\hat{\delta}_{true}$  is the SEY per penetrated current,  $I_{pen}$
- $I_{pen}$  is the fraction of  $I_{imp}$  not elastically scattered



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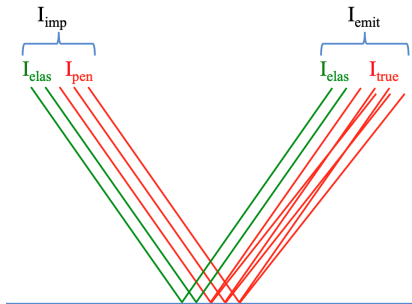
$$\hat{\delta}_{true} = \frac{I_{true}}{I_{pen}} = \frac{I_{true}}{I_{imp} - I_{elast}}$$



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$$\hat{\delta}_{true} = \frac{I_{true}}{I_{pen}} = \frac{I_{true}}{I_{imp} - I_{elas}}$$
$$= \frac{\delta_{true} I_{imp}}{(1 - \delta_{elas}) I_{imp}}$$

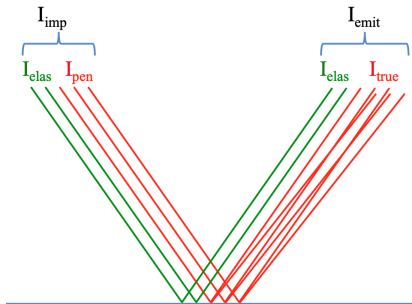




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- $\hat{\delta}_{true}$  is the SEY per penetrated current,  $I_{pen}$
- $I_{pen}$  is the fraction of  $I_{imp}$  not elastically scattered

$$\begin{aligned}\hat{\delta}_{true} &= \frac{I_{true}}{I_{pen}} = \frac{I_{true}}{I_{imp} - I_{elas}} \\ &= \frac{\delta_{true} I_{imp}}{(1 - \delta_{elas}) I_{imp}} = \frac{\delta_{true}}{1 - \delta_{elas}}\end{aligned}$$



# Comparison of simulation output

# Simulation setup

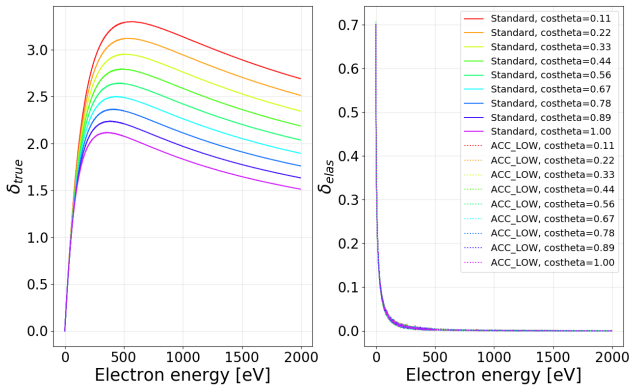
Simulations using the ECLLOUD and the ACC\_LOW secondary emission modules were carried out with the following parameters.

- 450 GeV beam energy
- $2 \cdot 10^{11}$  protons/bunch
- SEY parameter  $\delta_{max} = 2.0$
- Circular drift tube with 44 mm diameter

# Extracted SEY Curves

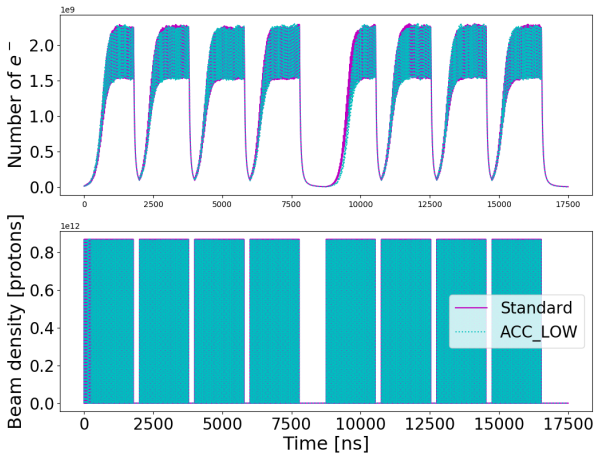
As expected, the extracted SEY curves from the two modules are the same.

Extracted SEY curves



# Electron cloud build-up

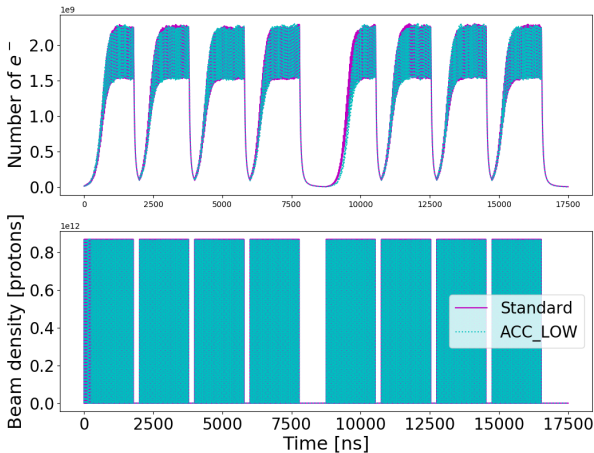
At first glance the simulation results look very similar.



# Electron cloud build-up

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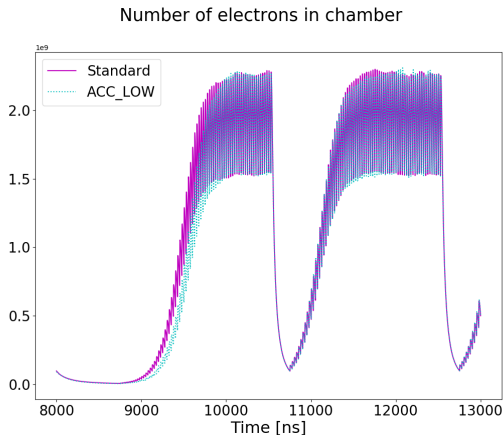
Let's zoom in on the first part of the second train.



# Electron cloud build-up

The buildup is slightly faster in the standard ECLLOUD model compared to the ACC\_LOW model.

Will this have an effect on the heat load?



# Heat load

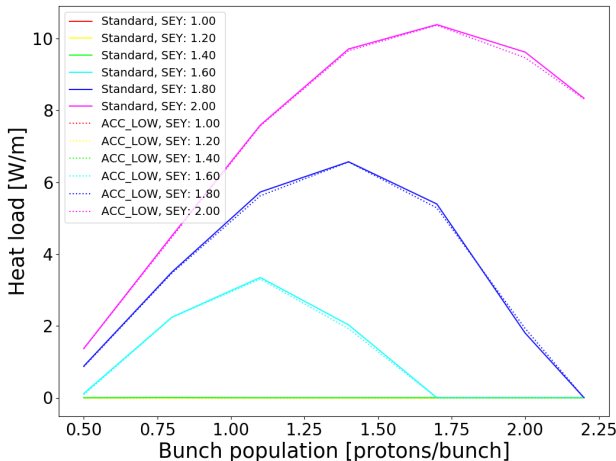
How does the  
produced heat load  
differ between the  
two models?



# Heat load

How does the produced heat load differ between the two models?

There are **no, or only very small, differences.**



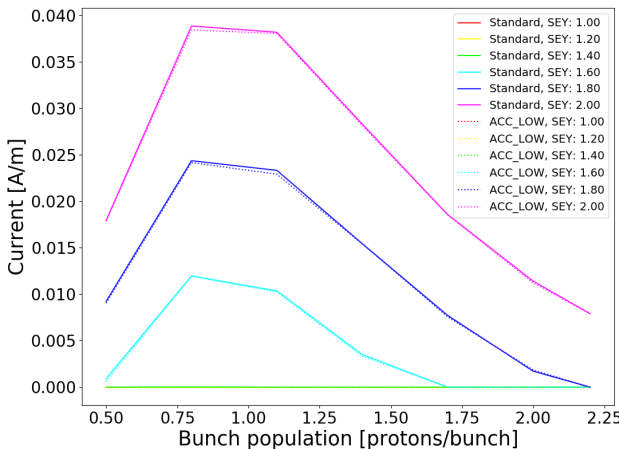
# Electron current

Let's also have a look at the current impacting on the beam screen.

# Electron current

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Again, **no, or very small, differences.**



# Summary

- We have studied and compared the secondary emission modules `sec_emission_model_ECLOUD.py` and `sec_emission_model_accurate_low_ene.py` in PyECLOUD.
- There is no difference in the  $\delta_{true}$  or  $\delta_{elas}$ .
- The electron cloud buildup is slightly slower with the `ACC_LOW` module.
- The differences in simulation output of observables like beam screen heat load and current are negligible.

# References



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<https://github.com/PyCOMPLETE/PyECLLOUD>, 2018.



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*Phys. Rev. ST Accel. Beams*, 5:124404, Dec 2002.



Giovanni Iadarola.

*Electron Cloud Studies for CERN Particle Accelerators and Simulation Code Development.*

PhD thesis, Università degli Studi di Napoli Federico II, Napoli, Italy, and European Organization for Nuclear Research (CERN), Geneva, Switzerland, March 2014.



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